



Docket No.: 689.006/10203084  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# 6  
Shang  
6/26/03

In re Patent Application of:  
Martin E. Fermann

Application No.: 10/085,620

Group Art Unit: 2873

Filed: March 1, 2002

Examiner: Ricky Levern Mack

For: CONFIGURATION OF AND METHOD FOR  
OPTICAL BEAM SHAPING OF DIODE  
LASER BARS

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Washington, DC 22313-1450

Dear Sir:

In response to the Office Action mailed May 20, 2003, Applicant elects Group I for prosecution on the merits.

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JUN 24 2003  
TECHNOLOGY CENTER  
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**REMARKS**

Applicant elects, without traverse, to prosecute Group I. Applicant believes that the following claims may correspond to FIG. 12 of Group I: 1-22 and 37-39.

The present election and designation of corresponding claims is made only for the purpose of complying with the election requirement and furthering prosecution. Applicant reserves the right to make any argument deemed necessary concerning the scope or proper construction of terms within the designated corresponding claims. Nothing in this response should be taken as an admission or disclaimer concerning the scope of the designated claims.

If the Examiner has any questions or comments in connection with the present response, she is respectfully invited to contact the undersigned to resolve any remaining issues to the extent necessary.